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Introduction

Following the isolation of graphene,¹ a major task has been to synthesize 2D materials compatible with the current semiconductor industry where silicon has the leading role. Suitable candidates are group-IV elements, namely Si, Ge and Sn with their respective 2D forms known as silicene, germanene and stanene.^{2–4} In their pure forms (*i.e.* without chemical functionalization) freestanding silicene and germanene films are predicted by theory to form slightly buckled structures with a mixture of sp² and sp³ hybridization.^{5,6} Experimentally, however, both silicene and germanene have only been realized on top of suitable substrates (*e.g.* Ag, Au, Ir).^{2,7}

While unmodified Si freestanding monolayer sheets are highly reactive, chemical modification can lead to the formation of stable 2D films as the unsaturated bonds become passivated. Functionalized Si films can be synthesized *via* a top-down approach that involves processing of calcium disilicide (CaSi₂), a suitable 3D layered precursor wherein Ca atoms are intercalated between 2D buckled silicene layers.⁸ Deintercalation of Ca atoms can be achieved *via* topochemical reactions with HCl (the so called Wöhler synthesis)⁹ leading to the formation of layered Si crystals known as siloxene $[SiH_6(OH)_3]^{10-14}$ or polysilane $(Si_6H_6).^{12,13,15}$ Several Density



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Topotactic transformations of suitable layered three-dimensional precursors are among the most robust methods to prepare two-dimensional (2D) materials based on silicon or germanium. Here we use Density Functional Theory calculations to probe the mechanisms underlying the formation of 2D-Si sheets functionalized with iodine atoms (SiI) or acetonitrile molecules [Si(MeCN)] starting from a layered CaSi₂ precursor. We identify the sequence of exothermic surface reactions that enable the adsorption of, not only iodine atoms, but, surprisingly, also of solvent acetonitrile molecules on both sides of the top layer of a Si-terminated CaSi₂ surface and its ensuing exfoliation as a standalone 2D sheet. In the acetonitrile case, the as-formed 2D material exhibits intriguing structural and electronic properties with an unusual quasi-one-dimensional substructure of silicon chains and a Dirac-like cone in the energy band diagram. The results elucidate the atomic-scale details of the established experimental technique of topotactic synthesis of functionalized silicene and identify new structural motifs for 2D materials.

Functional Theory (DFT) studies have investigated the structural and electronic properties of various types of 2D Si sheets functionalized with, e.g., hydrogen,^{14,16-19} halogens,¹⁸⁻²¹ and alkali metals,^{22,23} or with larger moieties such as hydroxyl,¹⁹ methyl,^{18,19} naphthyl/anthracyl,²⁴ phenyl,^{25,26} hydrocarbon²⁷ groups and others.^{2,28} In all these DFT studies, the 2D Si-based films were predicted to be semiconductors with band gaps covering a wide range of values from 0.26 eV to 2.5 eV. Based on these values, silicene derivatives are, in principle, suitable for applications such as photovoltaics, photodetectors, light-emitting diodes, and lasers.² Recent experimental studies²⁹⁻³³ have also highlighted their potential as anodes for lithium-ion batteries²⁹ and as biocompatible and biodegradable materials in cancer phototherapy.^{30,31} Intriguingly, these recent studies have suggested that freestanding silicene sheets without chemical modification can be synthesized via topochemical reactions of CaSi2 in a mixture of I2 and acetonitrile (CH₃CN), also known as methyl cyanide (MeCN), at room temperature.29-33

In this work, we employed extensive DFT calculations to probe the atomic scale mechanisms that underlie the topochemical synthesis of functionalized silicene sheets starting from a $CaSi_2$ precursor, with a focus on reactions in the presence of iodine and acetonitrile molecules. By doing that we have for the first time, to our knowledge, unravelled the series of exothermic reactions that give as exfoliated products Si-monolayers fully functionalized with iodine (in the following we use the symbol SiI for this 2D material) and 2D sheets of calcium diiodide (CaI₂). By the same token, we have found that



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Paper

full functionalization of silicene can occur also with acetonitrile molecules, even though the latter are typically regarded as relatively inert solvent species. The most stable structure of 2D sheets with acetonitrile functionalization [hereafter, we denote them as Si(MeCN)] comprises one-dimensional chains of Si atoms which are linked through pairs of acetonitrile anchors. The configuration is interesting not only because of this uncommon structural 2D arrangement, but also in terms of its electronic properties associated with the presence of small gaps and Dirac-like cones in the corresponding energy band diagram.

Methodology

Calculations for structural relaxations and electronic properties were performed with the Vienna Ab initio Simulation Package (VASP) software³⁴ and an energy cutoff of 400 eV for the plane wave basis. The interactions between valence electrons and ionic cores were described with projector augmented waves (PAW),³⁵ while exchange and correlation effects were accounted for through the Perdew-Burke-Ernzerhof (PBE) generalizedgradient approximation (GGA) functional, unless stated otherwise.36 Sampling of reciprocal space in total energy calculations was performed with the Monkhorst-Pack³⁷ method, whereas the tetrahedron method³⁸ was employed for summations in k-space to obtain the electronic densities of states (DOS). The sizes of the k-point grids were $12 \times 12 \times 1$ (4 \times 4×1) for the primitive cell (supercell) calculations, $8 \times 6 \times 1$ for the fully functionalized Si(MeCN) sheets and $2 \times 1 \times 1$ for the CaSi2 slab supercell. van der Waals interactions were included through the DFT-D3 method.39 For calculations on 2D materials and slabs, a vacuum of at least 20 Å was added in the z-direction to essentially eliminate interactions between periodic images. Ab initio molecular dynamics (AIMD) simulations were performed in a $2 \times 2 \times 1$ supercell of the most stable Si(MeCN) polymorph using a Nosé-Hoover thermostat in the canonical ensemble (NVT).

Results

In this work we used DFT calculations to study the interactions between freestanding silicene monolayers or CaSi₂ crystals with iodine and acetonitrile molecules. The following two subsections present the results for the freestanding films and CaSi₂ surfaces, respectively.

Iodine and acetonitrile adsorption on silicene

Pure silicene is a 2D allotrope of Si with a lattice parameter of 3.86 Å, a slightly buckled configuration of 0.45 Å (height difference between the two inequivalent atoms in the primitive cell) and a Si–Si bond length of 2.28 Å. Our results on the structural details of silicene are in excellent agreement with previous pertinent theoretical studies.^{5,6} Previous theoretical work has shown that functionalization of silicene with iodine (or other halogens) leads to the formation of stable 2D sheets with different possible geometries,^{20,21} the most stable of which is the so-called chair conformation shown in



Fig. 1 (a) Top (upper panel) and side (lower panel) views of silicene functionalized with iodine atoms (Sil) in the chair conformation. The black lines represent the primitive unit cell (a = 4.06 Å). (b) The starting (upper panel) and final (lower panel) configurations during the spontaneous dissociation of an I₂ molecule and adsorption of two I atoms on the silicene sheet. The final configuration is more stable than the initial one by 1.81 eV (Si: orange, I: purple spheres).

Fig. 1(a). Compared to pure silicene, SiI shows larger buckling at 0.68 Å, larger Si–Si bond lengths of 2.45 Å and a lattice parameter of 4.06 Å. The vertical distance between two I atoms of opposing sides is 5.53 Å, which is very close to the experimentally measured thickness (6.00 Å) of monolayer films synthesized from CaSi₂ crystals in the presence of I₂ in acetonitrile.²⁹ A notable feature of the structure is that the I atoms are not situated directly above or below the respective Si atoms to which they are bonded. As can be observed in the side view of Fig. 1(a), each I atom tilts at an angle of 76.8° relative to the horizontal plane of the film. We have found that it is this tilt which enhances the dynamic stability of the system by rendering all frequencies real in the corresponding phonon band diagram of Fig. S1 (ESI†). The material is stable also under strain with a well-defined and unique energy minimum, as shown in Fig. S2 (ESI†).

In terms of the electronic properties, Fig. S3 (ESI[†]) shows the electronic band structure of SiI for different strain levels along two vertical directions in the sheet, including the pristine case of the unstrained material. SiI is predicted to be a narrow-gap semiconductor with a direct band gap of 0.87 eV at the Γ point of the Brillouin zone. Calculations with the hybrid HSE06 exchange–correlation functional⁴⁵ widen the gap to 1.58 eV, while calculations based on the PBE0⁴⁶ xc-functional find a gap of 2.21 eV. By applying strain, the electronic properties of the material can be tuned further, as is demonstrated by the respective band structure diagrams of Fig. S3 (ESI[†]). A wide range of gap values can be achieved, ranging from 0.41 eV to 0.95 eV, while the direct/indirect nature of the band gap changes when strain is applied along the *a* axis.

For freestanding silicene to become fully functionalized as shown in Fig. 1(a), it must react exothermically with I_2 molecules. We modelled the interaction of an isolated I_2 molecule

on an orthogonal 15.45 Å \times 13.38 Å silicene supercell. We found that the molecule dissociates spontaneously (*i.e.* with no energy barrier) and its iodine atoms become adatoms on Si sites which are second neighbors as shown in Fig. 1(b). The absence of a reaction barrier and the strong energy gain of 1.81 eV shows that the functionalization of silicene with I species is a very efficient process.

On the other hand, the interaction of various organic molecules with silicene has been studied in previous theoretical works^{24,40-44} in relation to band gap engineering, molecule detection, energy storage and energy conversion. With respect to acetonitrile, however, to the best of our knowledge, there is only one DFT study⁴⁰ which probed just the physisorption of MeCN on silicene. Using the orthogonal 15.45 Å \times 13.38 Å silicene supercell we confirmed⁴⁰ that the most stable geometry of an isolated acetonitrile molecule is a physisorbed configuration wherein it lies parallel to the silicene sheet as shown in Fig. 2(a). The adsorption energy for the physisorbed state is 0.27 eV per MeCN molecule within the DFT-D3 approximation. On the other hand, the chemisorbed configuration of Fig. 2(b) for a molecule anchored to silicene through a N-Si bond has a lower adsorption energy of 0.16 eV, confirming that an isolated MeCN molecule is relatively inert.

However, when a second acetonitrile molecule is added to the system the situation changes drastically with the energy preference flipping in favor of a chemisorbed state. Fig. 2(c) shows the relaxed structure with two MeCN molecules bonded to the freestanding film. The N ends of each of the two molecules bind to two second-nearest Si neighbors on silicene, and a C–C bond (1.52 Å) is formed between them. The CH₃ groups of the protruding MeCN molecules point away from each other and form angles of about 120.0°, as expected for an sp² hybridization scheme. Through this reaction, the system gains an overall energy of 0.42 eV per MeCN with respect to a geometry where both MeCN molecules are physisorbed as in Fig. 2(a).

In contrast to SiI wherein each I atom binds to a single Si atom, we found that the N atom of a MeCN molecule can form



Interestingly, we have identified two such stable configurations (with real vibrational frequencies at the Γ point) whose tilt angles and energies differ, respectively, by only 5° and 0.5 meV per unit cell. Their band structure diagrams are shown in Fig. 4 (for the structure of Fig. 3, we term it Type 1a) and Fig. S4 (ESI†) (Type 1b). Both polymorphs have small direct band gaps (0.08 eV for 1a and 0.23 eV for 1b) at the Γ point with Dirac-like cones which are more prevalent for the Type 1a structure. The projected DOS plots (that of 1a is given in Fig. 5, the one for 1b is similar) show that the main contributions to the valence and conduction bands come from the s and p orbitals of Si and



Fig. 2 Side and perspective views of (a) physisorption and (b) chemisorption of an isolated MeCN molecule on silicene. (c) Chemisorption of two MeCN molecules forming a dimer on silicene. Binding energy per MeCN molecule is calculated at (a) 0.27 eV, (b) 0.16 eV and (c) 0.68 eV (Si: orange, N: blue, C: gray, H: white spheres).



Fig. 3 (a and c) Side views and (b) top view of the Type 1a Si(MeCN) 2D sheet. The dashed lines represent the primitive cell (Si: orange, N: blue, C: gray, H: white spheres).



Fig. 4 Electronic band structure of the Type 1a Si(MeCN) sheet. The valence band maximum is set to 0 eV and the inset shows the first Brillouin zone and corresponding high symmetry points.



Fig. 5 Projected electronic density of states (pDOS) for the s orbitals of Si and H, and the p orbitals of Si, N and C of the Type 1a Si(MeCN) sheet. The valence band maximum is set to 0 eV.

the p orbitals of N and C. Calculations with the hybrid HSE06 xc-functional of the eigenenergies at band edges give gaps of 0.06 eV and 0.29 eV for, respectively, Type 1a and 1b. When strain (up to 1%) is applied to 1a the gap is slightly modified between 0.07 eV and 0.14 eV, as is depicted in the corresponding band diagrams of Fig. S5 (ESI†). Moreover, as is shown in Fig. S6 (ESI†), Type 1 structures are stable under applied strains of up to 3%.

Fig. S7(a) (ESI[†]) shows another polymorph (Type 2) which is less stable than Type 1 by 0.12 eV per Si atom. This structure is similar to Type 1 in terms of bonding, but differs in that its MeCN dimes do not tilt away from the upright position with respect to the horizontal backbone of the 2D sheet. Moreover, because of the alternate tilting pattern described above, the unit cell of Type 1 is twice the size of that of Type 2 along the

b-axis. Fig. S7(b) and S8(a) (ESI⁺) show the next two most stable polymorphs (Type 3 and Type 4) whose energies are 0.37 eV per Si higher than those of Type 1. In Type 3, half of the N atoms are two-fold coordinated and the rest are three-fold coordinated, while all Si atoms have four bonds. We have also identified another three possible conformations (Types 5-7) shown in Fig. S8 and S9 (ESI[†]). The structure of Type 3 resembles the Type 1 geometry on one side (N atoms have three bonds), while the other side is akin to the Type 2 configuration with two-fold coordinated N atoms. In Types 5-7 all N atoms bind to a single Si atom on the hexagonal silicon sheet. They differ in how the C-C bonds in the MeCN dimers are oriented above and below the silicene-like network. Types 5-7 are significantly less stable by 0.65-0.74 eV per Si atom compared to Type 1. The relative stabilities and structural properties of all polymorphs are summarized in Table S1 (ESI[†]).

The electronic DOS for Types 2–7 are given in Fig. S10 (ESI†) and the corresponding band gap values are also summarized in Table S1 (ESI†). At the PBE-GGA level, Types 3 and 7 are metallic, Type 2 is a semiconductor with a very small gap of 0.07 eV and Types 4–6 are also semiconductors but with slightly large band gaps in the range 0.30–0.62 eV. Calculations with the HSE06 functional⁴⁵ widen the gaps to 0.54–1.31 eV.

In terms of the energies for the synthesis of fully functionalized SiI or Si(MeCN) with respect to freestanding silicene and free I_2 or MeCN molecules, the reactions can be described by the equation:

$$\Delta E = \frac{1}{n} \left| E_{\text{product}}^{\text{total}} - \left(E_{\text{silicene}}^{\text{total}} + n \times E_{\text{molecule}}^{\text{total}} \right) \right|$$
(1)

where $E_{\text{product}}^{\text{total}}$ is the total energy of fully functionalized silicene with I (chair conformation) or MeCN (Type 1 conformation), $E_{\text{silicene}}^{\text{total}}$ is the total energy of pristine silicene and $E_{\text{molecule}}^{\text{total}}$ is the total energy of a free I₂ or MeCN molecule. The factor *n* is the number of Si atoms in the primitive cell in each case which also corresponds to the number of I atoms or MeCN molecules required to fully functionalize the sheets. Similar methodology has been used in previous DFT studies to calculate the formation energy of halogenated silicene films, including SiI.²¹ Results show that the formation of both sheets is favored, with the reactions being exothermic releasing an energy ΔE of 1.08 eV per Si in the case of SiI (in agreement with previous DFT work²¹) and 1.61 eV per Si in the case of Si(MeCN).

Topochemical reactions of CaSi2 with iodine or acetonitrile

In order to assess the possibility of synthesizing SiI and Si(MeCN), we studied how a $CaSi_2$ crystal reacts with I_2 and acetonitrile molecules. $CaSi_2$ is a 3D layered crystal with a trigonal structure of group symmetry $R\bar{3}m$.⁸ The calculated PBE-GGA values for the *a* and *c* lattice parameters (respectively, 3.84 Å and 15.84 Å) are in excellent agreement with the experimental values.⁸

To model the Ca- and Si-terminated $CaSi_2$ surfaces, we simulated slabs with at least 20 Å of vacuum in the *z*-direction using the theoretically predicted lattice parameters of bulk $CaSi_2$. The supercell consisted of 6 atomic layers in total (3 Ca and 3 Si) and the atoms of the bottom layer were kept fixed during relaxation. The unit cells are highlighted with the



Fig. 6 The (a) Ca-terminated and (b) Si-terminated surfaces of a CaSi₂ crystal passivated with iodine or acetonitrile (Ca: green, Si: orange, I: purple, N: blue, C: gray, H: white spheres).

dashed lines in Fig. 6. The most stable geometries for the Si-terminated surface are similar to the case of freestanding silicene, resembling the chair conformation for SiI and forming dimers in the case of MeCN molecules. The Ca-terminated surface passivated with iodine resembles the trigonal structure of CaI₂, and in the case of acetonitrile the MeCN molecules form dimers through a C–C bond similar to the Si-terminated surface. In addition, we find that both Ca- and Si-terminated surfaces react exothermically with iodine and acetonitrile. To calculate the energy gained through these reactions we used the following equation:

$$\Delta E = \frac{1}{n} \left(\left| E_{+n}^{\text{CaSi}_2} \right| - \left| E_{\text{bare}}^{\text{CaSi}_2} + n \times E_{\text{mol}}^{\text{free}} \right| \right)$$
(2)

where $E_{+n}^{\text{CaSi}_2}$ is the total energy of a CaSi₂ supercell with *n* adsorbed I atoms or MeCN molecules, $E_{\text{bare}}^{\text{CaSi}_2}$ is the total energy of the bare supercell (without I or MeCN) and $E_{\text{mol}}^{\text{free}}$ is $\frac{1}{2}$ of the total energy of a free I₂ molecule or the total energy of a free MeCN molecule respectively. The energy gain (per I atom or per MeCN molecule) for the Ca surface is 2.72 eV (1.89 eV) for I atoms (MeCN molecules), while for the Si surface the energy gain is calculated at 1.14 eV (1.12 eV) for I atoms (MeCN molecules) with all values suggesting that CaSi₂ surfaces tend to react readily with both I₂ and MeCN.

Experimentally, during the chemical treatment of CaSi₂ (e.g. with aqueous HCl^{11} or I_2 in acetonitrile²⁹) Ca atoms are gradually deintercalated from the material when the crystal is left long enough in the solution. In order to reach complete deintercalation and achieve the synthesis of the fully functionalized SiI or Si(MeCN) sheets, these processes must progress towards the bulk of the material from the exposed surfaces of the crystals, with I2 or MeCN molecules inserted between the Ca and Si layers. The results discussed in the previous paragraph showed that reactions of iodine or acetonitrile with the (001) surface of CaSi2 crystals are exothermic processes. Here, we look further into how these reactions progress within the material from an exposed CaSi2 side surface. To simulate the slab, we used an orthogonal supercell of dimensions 7.68 Å \times 26.61 Å \times 15.84 Å (along the x, y and z directions respectively) with six atomic layers (three Ca and three Si) and an added 20 Å of vacuum in the y and z axes as depicted in Fig. S11 (ESI[†]). The top surface was Si-terminated and the atoms of the bottom Ca layer were kept fixed during relaxations to simulate the bulk of the material. The total number of atoms



Fig. 7 Energy change (black squares) during successive reactions of iodine molecules on a $CaSi_2$ slab. The insets show the relaxed structures for selected values n_{l_2} of adsorbed l_2 molecules (Ca: green, Si: orange, I: purple spheres).

in the bare supercell were 48 Ca and 96 Si atoms and the energy released during successive reactions was calculated according to eqn (2).

Fig. 7 shows the change in energy as more and more I_2 molecules are adsorbed on the CaSi2 slab. The zero of energy is taken to be the total energy of the fully passivated slab as shown in the inset of Fig. 7 for n_{I_2} = 0. Extra I_2 molecules are gradually inserted from the side between the top Si layer and the Ca layer underneath. The relaxed structures for some representative cases are shown in the insets of Fig. 7. As more I_2 molecules are added to the system, the top Si layer is gradually detached and iodine is adsorbed also on the bottom side of the Si sheet. Simultaneously, the exposed Ca layer gets passivated by iodine atoms that assume positions of the trigonal CaI2 crystal, similar to what is observed for the Ca-terminated surface [Fig. 6(a)]. All adsorption steps are found to be exothermic. In the final configuration ($n_{I_2} = 16$) the top Si layer has been completely functionalized with iodine and becomes detached from the surface of the crystal. The fact that there is no energy penalty in our calculations serves as a theoretical proof of principle that CaSi₂ crystals can react with iodine to produce fully functionalized Si. It is well known that similar topochemical reactions occur in the hydrogenation of silicene or germanene^{47–50} and in other materials as well,^{51,52} but, to our knowledge, this is the first time that the atomic details of these transformations are elucidated with first principles calculations. We should also note that we tested the effect a proximal solvent acetonitrile molecule may have on the exothermic insertion of iodine atoms and found it to be minimal. In particular, for the step that adds a second iodine pair in Fig. 7 the reaction energy is 4.32 eV. This is to be compared to the value of 4.20 eV obtained without this MeCN molecule. The fact that the two values are so close to each other suggests that the presence of solvent molecules does not alter significantly the energetics of I-functionalization we analyzed above.

After the removal of the top layer in the form of a functionalized Si sheet, the CaSi2 crystal is left with an exposed iodinated Ca-terminated surface. Using the orthogonal cell of the bare Ca-terminated surface depicted in Fig. 6(a), we show that successive reactions with iodine can also lead to the removal of the top Ca layer in the form of CaI₂. The relaxed structures and total energy change ΔE per cell (eqn (2)) are given in Fig. S12 (ESI[†]). It turns out that it is favorable for iodine to react with Ca atoms and produce a CaI₂ layer that is very weakly bound to the Si layer beneath it, both for the unpassivated [Fig. S12(c), ESI[†]] and the fully passivated case [Fig. S12(d), ESI[†]]. In this manner, the reaction cycle of Fig. 7 is reset and the process may progress to the next Si layer until the whole crystal is deintercalated leading to the synthesis of SiI. Notably, the same topotactic reaction leads to the formation of a second 2D material, namely CaI₂ films⁵³⁻⁵⁶ as shown in Fig. S12(d) (ESI[†]). This is an important finding as it provides an alternative and straightforward route for the synthesis of twodimensional CaI₂.

On the other hand, in order to synthesize Si sheets fully functionalized with acetonitrile, MeCN molecules should



Fig. 8 Relaxed configurations of a CaSi₂ slab model, where Si atoms on the top surface are passivated with acetonitrile molecules and Si atoms on the sides are passivated with H (with different levels of passivation for the top Si layer in cases a–d and e, f). Panels (b), (d) and (f) are the configurations of panels (a), (c) and (e) respectively with an extra acetonitrile molecule inserted between the top two layers (red circles). With respect to the total energy of the configuration in (a) plus that of a free MeCN molecule, structure (b) is less stable by 0.97 eV. By the same token the configuration in (d) is less stable than (c) by 1.97 eV and configuration (f) is less stable than (e) by 2.33 eV (Ca: green, Si: orange, N: blue, C: gray, H: white spheres).

adsorb exothermically on both sides of the Si surface sheet. To investigate this reaction, we used a model of a CaSi₂ slab where, in this case, Si atoms on the edges of the crystal are passivated with H atoms on the exposed sides as shown in Fig. 8(a). Fig. 8(b) shows the relaxed configuration of the same supercell with an extra MeCN molecule positioned between the top two layers. We compared the total energy of this final configuration to the sum of the total energy of Fig. 8(a) plus a free MeCN molecule (to conserve the total number of atoms) and it turns out that Fig. 8(b) is less stable by 0.97 eV. We also tested different levels of passivation for the $CaSi_2$ crystals [Fig. 8(c-f)] with and without an inserted MeCN molecule and the respective energy differences are 1.97 eV and 2.33 eV. Because of this first endothermic step, the insertion of acetonitrile molecules in-between the layers of a CaSi₂ crystal and, concomitantly, the complete topotactical synthesis of 2D-Si(MeCN) will require annealing at elevated temperatures, possibly in the range of 200–500 °C. The quantitative estimate of the activation energy and temperature requires, of course, a much more involved and

large-scale simulation which goes beyond the scope of the present study.

Conclusions

Using DFT calculations we probed the atomic-scale details of the topochemical reactions of iodine and acetonitrile molecules with freestanding silicene and CaSi₂ crystals. We demonstrated that I₂ species react with the crystal surfaces to produce fully passivated SiI films and that all relevant reaction steps are exothermic. Furthermore, we identified novel 2D Si sheets functionalized with acetonitrile that include narrow-gap semiconductors and metals, adding new functional members in the family of 2D forms of silicon. Given the rich possibilities with respect to the choice of solvents and/or oxidants (*e.g.* I₂, HCl) in the topochemical deintercalation of CaSi₂, our results serve as a proof of principle that more complex structures of 2D Si can be synthesized by combining different molecules that form bonds not just with the Si sheet, but also with each other.

Conflicts of interest

There are no conflicts to declare.

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